



Resistive Silicon Detector: 4D tracking with low electrode density

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on behalf of the 4DSHARE project

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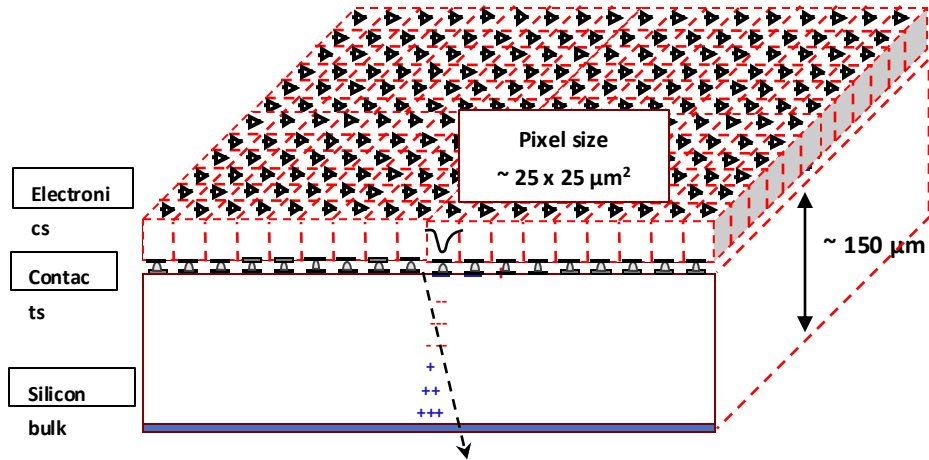


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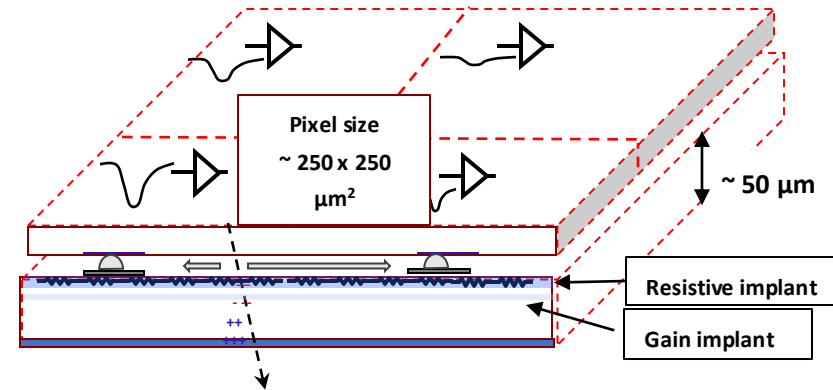


The motivation: silicon trackers using “resistive read-out”

Standard pixelated silicon sensor



Resistive Silicon Detector (RSD)



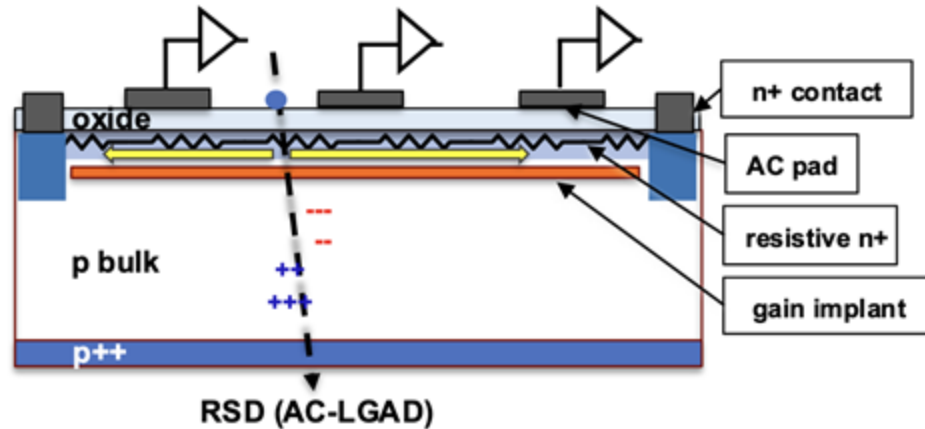
- **Standard pixel sensor:** binary read-out with a **space resolution** $\sigma_{\text{pixel}} \sim 0.3 \cdot \text{pitch}$
- **Resistive silicon detector** based on LGAD technology:
 - **space resolution** $\sigma_{\text{pixel}} \sim 0.03\text{-}0.05 \cdot \text{pitch}$ (3%-5% of the pitch)
 - **Time resolution of 30-40 ps**
 - **Fill factor close to 100%**

RSD sensors have similar space resolution of standard pixel sensors, with number of read-out channels ~100 lower

lower material budget and power consumption

Resistive silicon Detectors – the technology

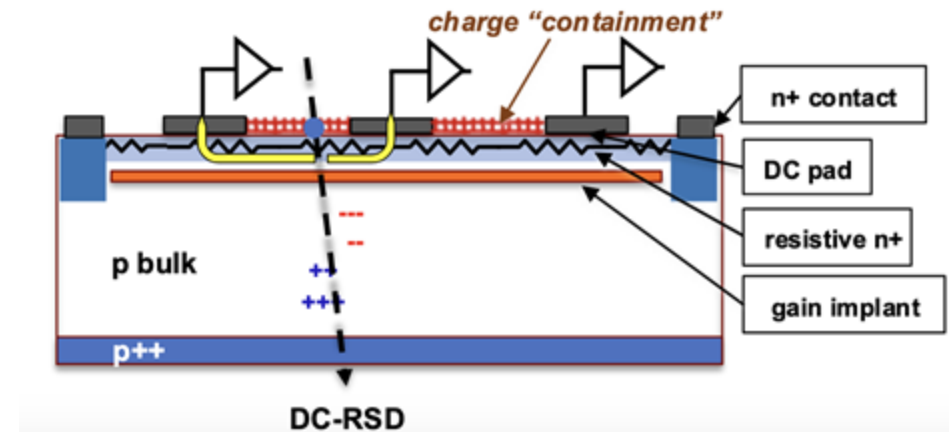
AC-Coupled Resistive silicon Detectors



Main Characteristics of AC-RSD:

- Fill factor of 100%
- Bipolar signals with long second lobe
- Baseline fluctuation (leakage current collected at the sensor edge)
- Signal confinement determined by the resistive electrode and coupling capacitance

DC-Coupled Resistive silicon Detectors

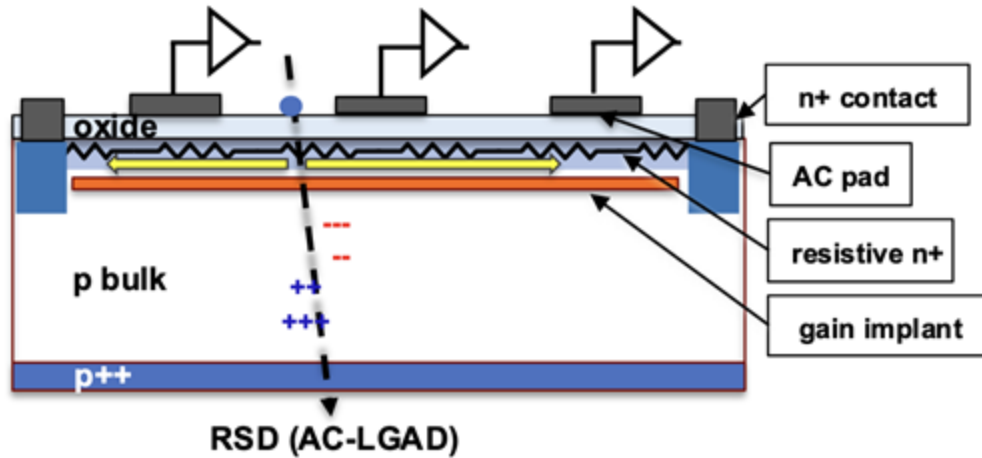


Main Characteristics of DC-RSD:

- Excellent Signal confinement obtained with trenches
- Fill factor $\sim 99\%$
- Unipolar signals

AC-Resistive silicon Detectors

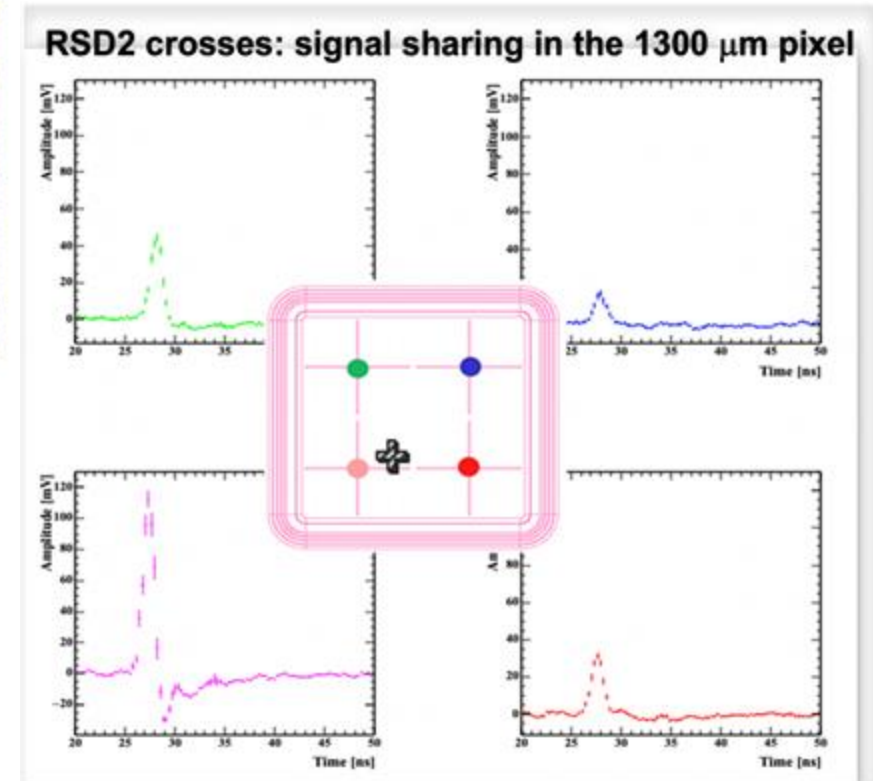
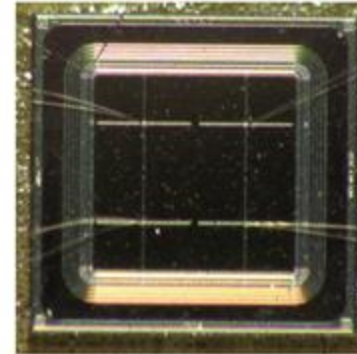
AC-Coupled Resistive silicon Detectors



The proof-of-concept of signal sharing with resistive read-out in silicon sensors

- RSD1 batch
- RSD2 batch

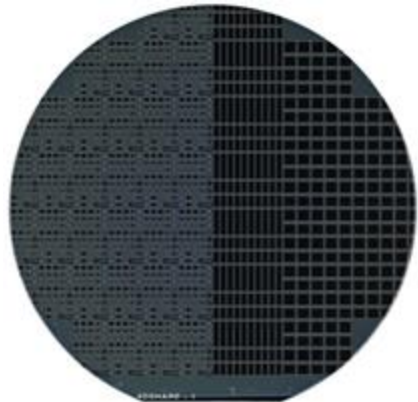
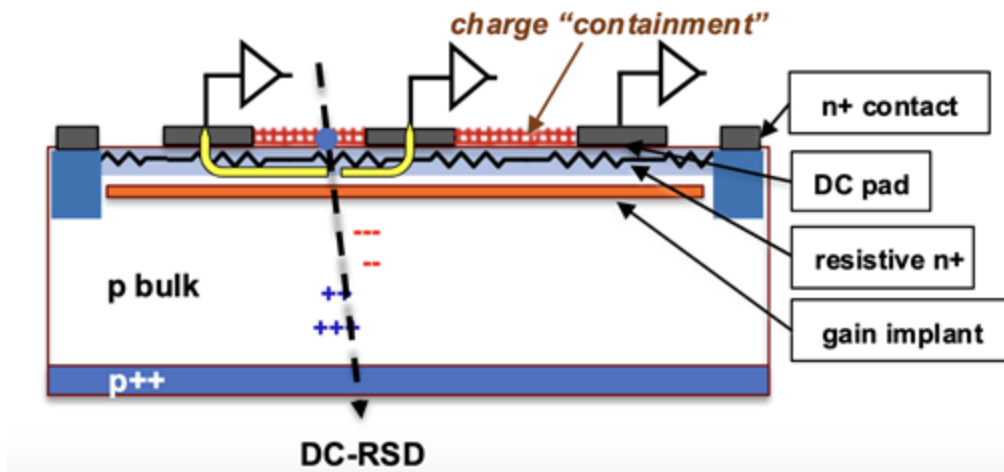
The RSD batches have been funded by INFN CSN5



- Bipolar signals with long second lobe
- Signal amplitude related to the position of the hit

DC-Resistive silicon Detectors

DC-Coupled Resistive silicon Detectors



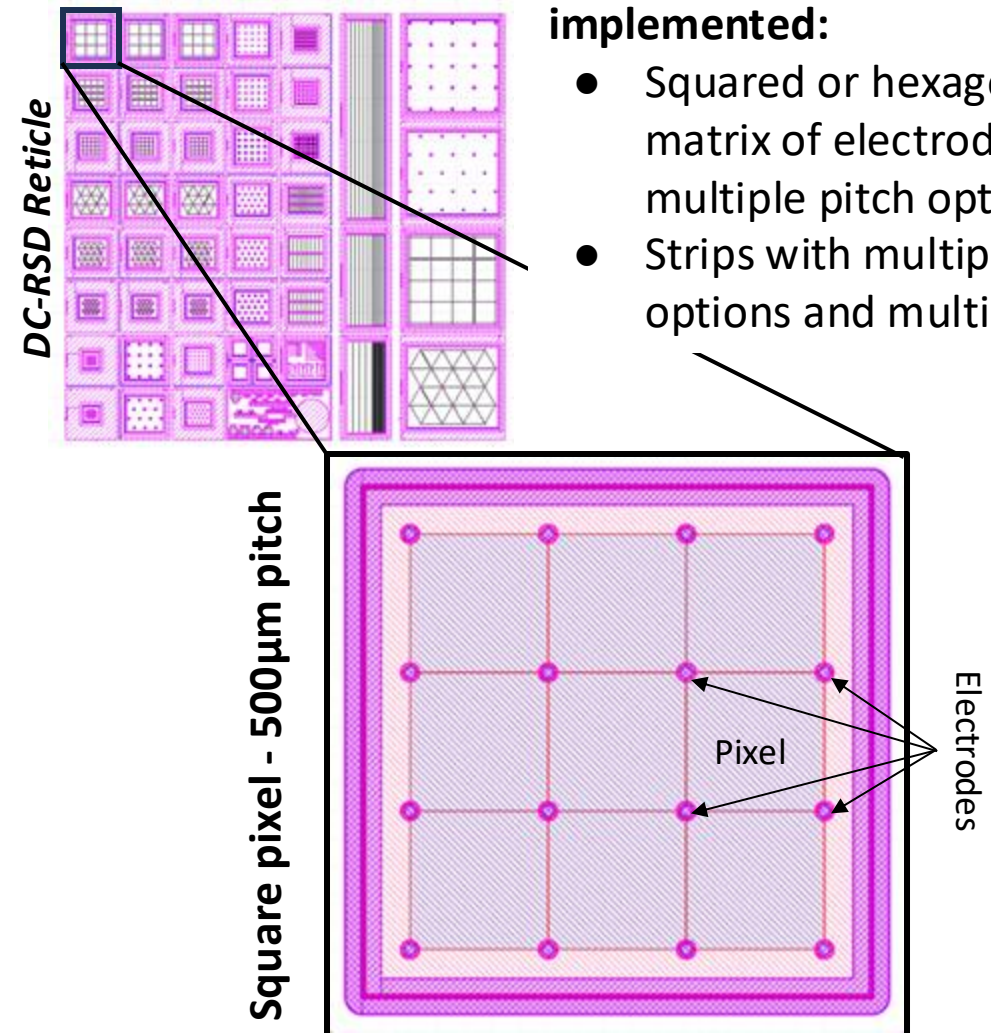
DC-RSD wafer

The first DC-RSD production was released by FBK in November 2024

The production was funded by INFN CSN5 through the 4D-SHARE project

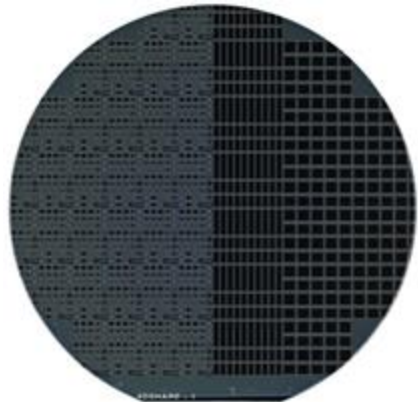
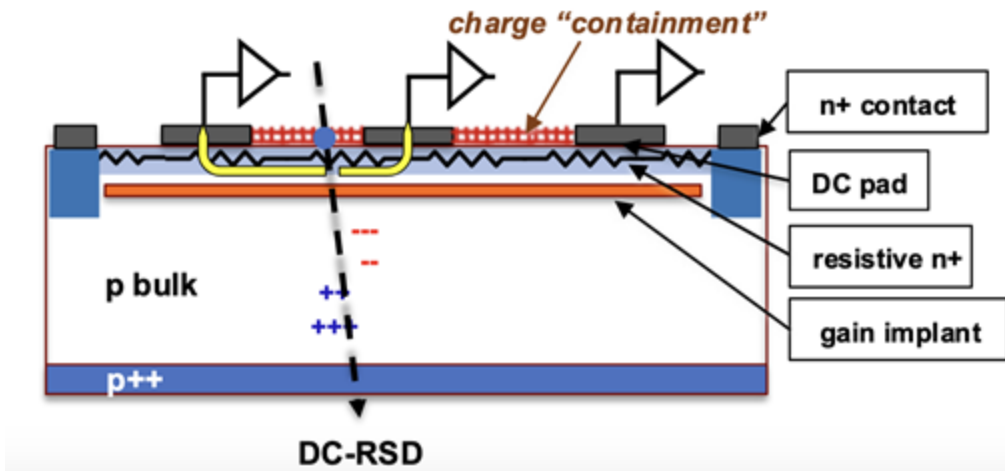
Several test structures implemented:

- Squared or hexagonal matrix of electrodes with multiple pitch options
- Strips with multiple pitch options and multiple length



DC-Resistive silicon Detectors

DC-Coupled Resistive silicon Detectors



DC-RSD wafer

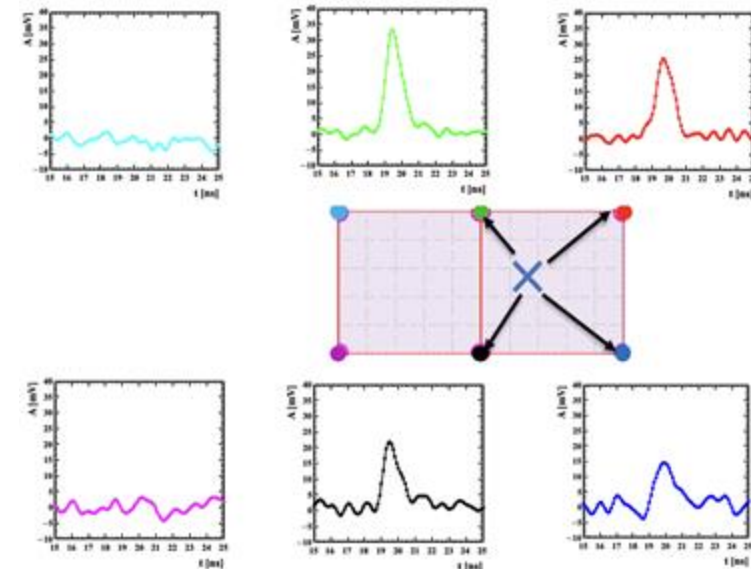
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Hit inside the pixel:

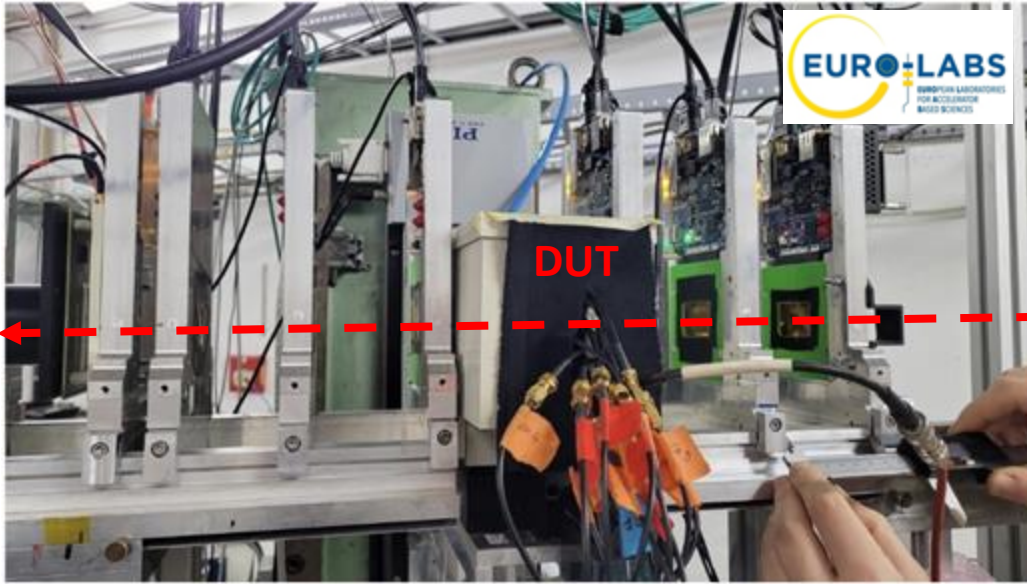
- **Signal sharing** between 4 electrodes
- **Perfect isolation**: the signal is seen only in the electrodes belonging to the hit pixel

Square pixel - 500 μ m pitch



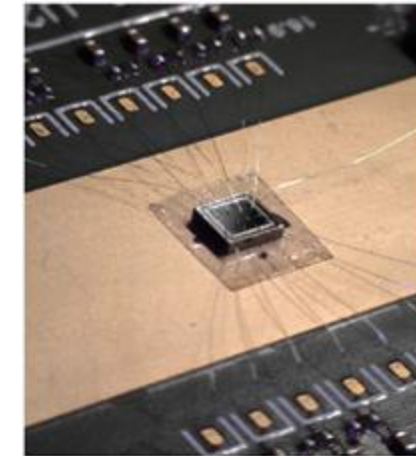
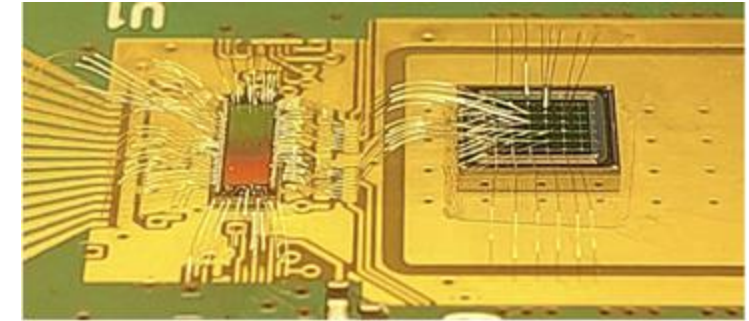
Beam test activities

Space and time resolutions have been studied in several beam tests at DESY facility

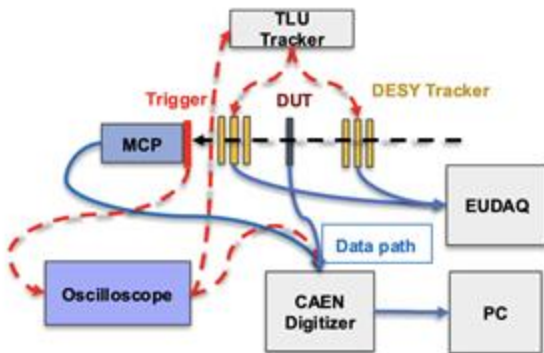


e^- beam
 $E=4.5$ GeV

AC-RSD (5x5 matrix) read out by FAST ASIC



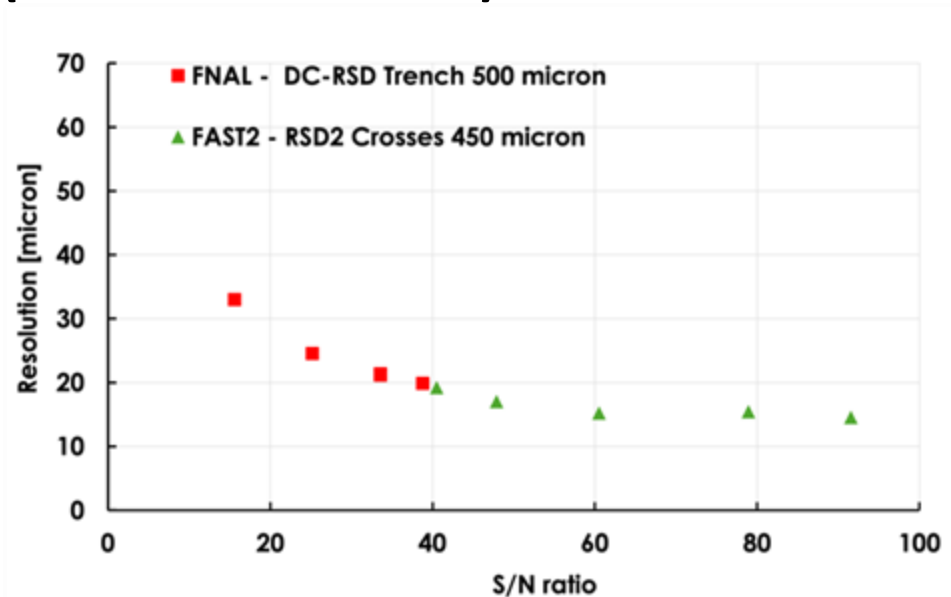
DC-RSD (Square pixel -
500μm pitch) wire
bonded to 16ch board



Beam test setup for
study of spatial
resolution

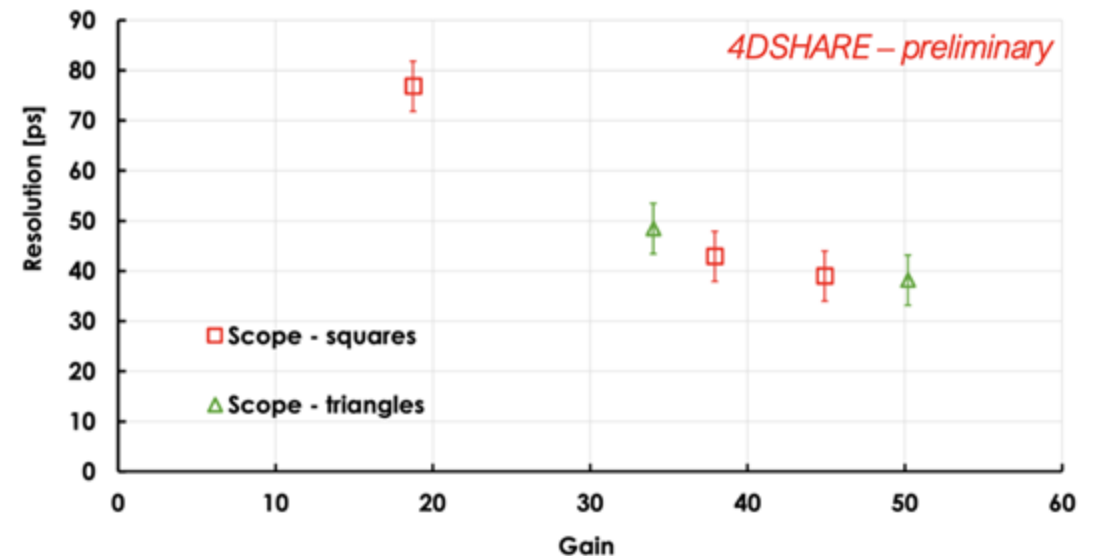
RSD resolution: space and time

Space resolution for DC-RSD 500- μm pitch square and AC-RSD 450- μm pitch square (crosses electrode)



- Space resolution $< 20 \mu\text{m}$ for S/N ratio larger than 40
- Space resolution is **4-5% of the pixel pitch**

Time resolution for the 500- μm pitch square and triangular pixel matrix



- Time resolution $\sim 40 \text{ ps}$ for gain larger than 40

References

- L. Menzio et al, “First test beam measurement of the 4D resolution of an RSD 450 microns pitch pixel matrix connected to a FAST2 ASIC”,)NIMA 1065 (2024), 169526
- F. Moscatelli et al, <https://www.sciencedirect.com/science/article/pii/S0168900224003061>
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- M. Centis Vignali's, “Development and Wafer-level Characterization of the First Production of DC-RSD Sensors at FBK”, TREDI2025, <https://indico.cern.ch/event/1455346/abstracts/185675/>
- N. Cartiglia, “Test beam characterisation of the first DC-coupled Resistive Silicon Detector FBK production”, TREDI2025, <https://indico.cern.ch/event/1455346/abstracts/185577/>
- R. Arcidiacono, “[Innovative DC-coupled Resistive Silicon Detector for 4D tracking](#)”, VCI2025, <https://indico.cern.ch/event/1386009/contributions/6279050/>

Acknowledgment

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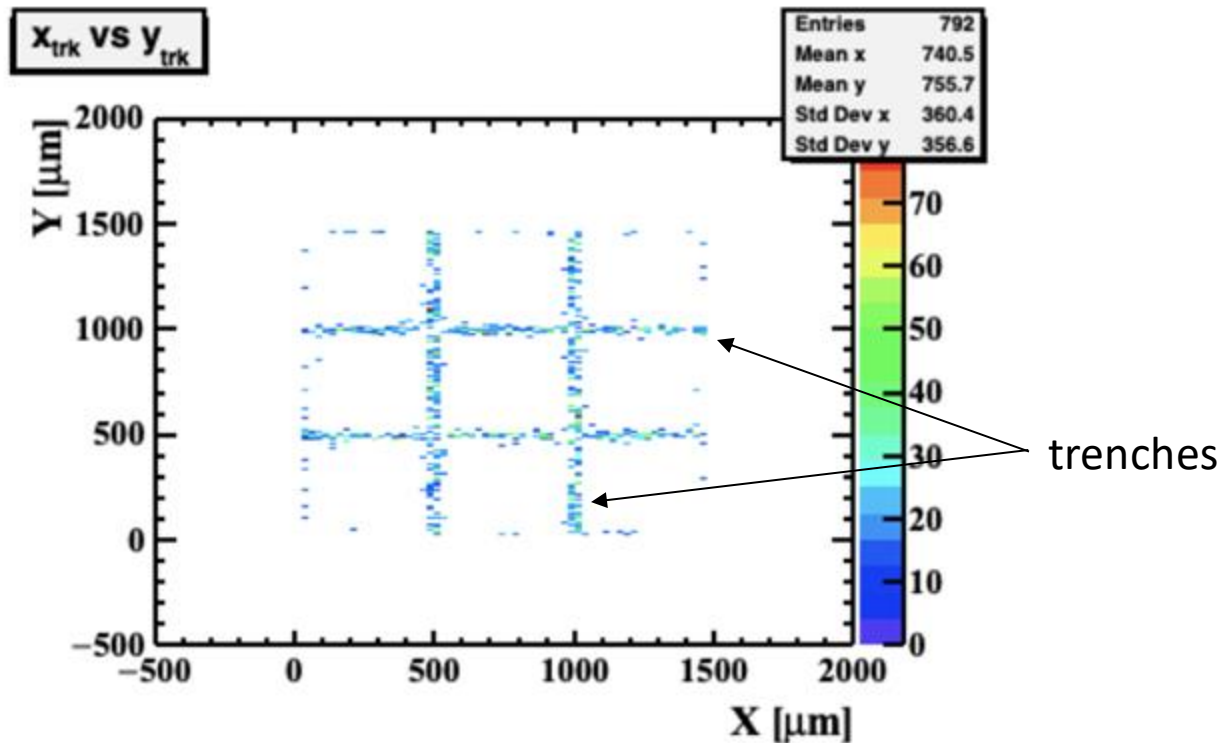
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Backup

Fill factor of DC-RSD



Selections:

- Events with tracks inside the active area and
- Amplitude of the signal < 25 mA

Fill Factor of $\sim 99\%$

DC-RSD signal containment

Average signal amplitude seen by each electrode as a function of the $(X,Y)_{\text{TRACKER}}$

